PATENTS

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Masakazu KOUDU

Serial No. 10/025,470

GROUP

2121

Filed

December 26, 2001

Examiner Unassigned

MEMORY MANAGEMENT FOR OPTIMAL STORAGE OF DATA OF ANY SIZE IN MEMORY

INFORMATION DISCLOSURE STATEMENT

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Commissioner for Patents

MAR 2 2 2002

Washington, D.C. 20231

Technology Center 2100

Sir:

In compliance with Rules 1.97 and 1.98, and in fulfillment of the duty of disclosure under Rule 1.56, the accompanying documents, copies of which are attached to this statement, are made of record on the enclosed sheet.

A concise explanation of the relevance of these items is that these references were cited by the New Zealand Patent Office in the corresponding New Zealand application Serial No. 516063. A copy of the New Zealand Official Action in which they were cited is attached hereto.

Respectfully submitted,

YOUNG & THOMPSON

Robert J. Patch Attorney for Applicant Registration No. 17,355 745 South 23rd Street Arlington, VA 22202 Telephone: 703/521-2297

March 15, 2002

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FORM PTO-1449 U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use several sheets if necessary)

ATTY. DOCKET NO.
NEC01P227

SERIAL NO. 10/025,470

APPLICANT

Masakazu KOUDU

FILING DATEOO

December 26, 2001

GROUP 2121

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			U.S. PA	TENT DOCUMENTS			
EXAMINER INITIAL		PATENT NUMBER	ISSUE DATE	PATENTEE	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
	AA	4,315,312	02/82	Schmidt			
	AB	4,809,234	02/89	Kuwashiro			
	AC						
	AD						
_	AE						
	AF						
	AG						
FOREIGN	PATENT	OR PUBLISHED FORE	IGN PATENT A	APPLICATION			
		DOCUMENT NO.	PUBL. DATE	COUNTRY OR PATENT OFFICE	CLASS	SUB CLASS	TRANSLATION YES NO
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OTHER DO	CUMEN'	TS (Including Author	, Title, Date, I	Relevant Pages, Place of i	Publication)	
•	AT						
	AU						
	AV						
EXAMINER				DATE CONSIDERED			

EXAMINER: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of

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this form with next communication to applicant.

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